## **Electronic Information Disclosure Statement**

## **CVD APPARATUS**

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Applicant(s):

Ge XU

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Docket

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**Group Art Unit:** 

Examiner:

S. MacArthur

search string:

( 5433786 or 5472565 or 5624498 or 5766364 or 6086677 or 6203620 or 6245396 or 6245192 or

6368987 or 6435428 or 6302964 ).pn.

## **US Patent Documents**

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

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## Signature

Examiner Name	Date	
Iylvi RMader	9/25/03	